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RSC Advances

SUPPORTING INFORMATION

Fabrication of well-ordered silicon nanopillars embedded in a microchannel via metalassisted chemical etching: A route towards an opto-mechanical biosensor

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Fig. S1. (A) SEM image of SiNPs build inside the SU-8 microchannel (*Top view*). (B) Morphological operations of the SEM image to determine the location of the nanopillars. (C) Position assignation of the nanopillars using the Analyze particle tool of the ImageJ software [1]. (D) Calculation of the pair correlation function g(r) to determine the correlation length κ [2], [3] using the software R with the library "spatstat" [4]. (E) Fitting of the envelope of the pair correlation function by an exponential decay function ($exp(-r/\kappa)$) to calculate the correlation length.

r (nm)



Fig. S2. Comparison of SiNPs fabricated inside the SU-8 microchannel with those built on a flat silicon wafer. For each image (*top view*) the correlation length was calculated demonstrating that the degree of ordering is preserved in those arrays of SiNPs contained in the microchannel. The RIE recipe for each case is: (A)70 s, (B)70 s, (C)100 s and (D)100 s, respectively.

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